Searches for User *gverbitsky* (Count = 37661)

Queries 37612 through 37661.

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S #	Updt	Database	Query	Time	Comment
S37661	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/185 and (substrate resistance or substrate resistor)) and (membrane or diaphragm)	2006-01-19 16:51:13	
S37660	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/185) and (substrate resistance or substrate resistor)	2006-01-19 16:46:38	
S37659	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	374/185	2006-01-19 16:46:08	
S37658	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	((MEMBRANE OR DIAPHRAGM) adj5 (resistance)) and (substrate adj5 resistance)	2006-01-19 16:05:25	
S37657	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(MEMBRANE OR DIAPHRAGM) adj5 (resistance)	2006-01-19 16:04:58	
S37656	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/29 and (substrate or wafer)) and (MEMBRANE OR DIAPHRAGM)	2006-01-19 15:53:29	
S37655	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/29) and (substrate or wafer)	2006-01-19 15:23:21	
S37654	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	374/29	2006-	

				01-19 15:23:05
S37653	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (MEMS) and (substrate or wafer or silicon)) and (disphragm or membrane)	2006-01-19 15:13:32
S37652	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (MEMS)) and (substrate or wafer or silicon)	2006-01-19 15:13:05
S37651	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls.) and (MEMS)	2006-01-19 15:12:44
S37650	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	bulk adj5 silicon	2006-01-19 15:12:11
S37649	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	bulk silicon resistance	2006-01-19 15:09:31
S37648	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	bulk substrate resistance	2006-01-19 15:08:36
S37647	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(diaphragm temperature or temperature diaphragm) and (substrate temperature or temperature substrate or wafer temperature or temperature wafer)	2006-01-19 14:34:52
S37646	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	((diaphragm resistance or resistance diaphragm) and (substrate resistance or resistance substrate or wafer resistance or resistance wafer)) and (temperature)	2006-01-19 14:26:34

S37645	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(diaphragm resistance or resistance diaphragm) and (substrate resistance or resistance substrate or wafer resistance or resistance wafer)	2006-01-19 14:23:27
S37644	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	((diaphragm resistance)) and (substrate resistance)	2006-01-19 14:21:27
S37643	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(diaphragm resistance)	2006-01-19 14:21:10
S37642	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (temperature sens$4 resist$4 or temperature measur$4 resist$4) and (substrate or wafer)) and (diaphragm)	2006-01-19 13:38:19
S37641	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (temperature sens$4 resist$4 or temperature measur$4 resist$4) and (substrate or wafer)) and (membrane or diaphragm)	2006-01-19 13:38:00
S37640	U	USPT	5177696.pn. and (second temperature or second resist$4)	2006-01-19 13:26:14
S37639	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (temperature sens$4 resist$4 or temperature measur$4 resist$4)) and (substrate temperature or	2006-01-19 12:53:20

			substrate resistance)	
S37638	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (temperature sens$4 resist$4 or temperature measur$4 resist$4) and (substrate or wafer)) and (membrane or frame)	2006-01-19 12:26:04
S37637	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (temperature sens$4 resist$4 or temperature measur$4 resist$4)) and (substrate or wafer)	2006-01-19 12:25:51
S37636	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls.) and (temperature sens$4 resist$4 or temperature measur$4 resist$4)	2006-01-19 12:25:17
S37635	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(membrane resistor or resistor membrane) and (substrate resistor or wafer resistor)	2006-01-19 12:05:58
S37634	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(membrane resistance or resistance membrane) and (substrate resistance or wafer resistance)	2006-01-19 11:42:41
S37633	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(resistance membrane) and (resistance substrate or resistance wafer)	2006-01-19 11:39:59
S37632	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	resistance membrane	2006-01-19 11:39:41
S37631	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	thermistor on membrane	2006-01-19

				11:39:21
S37630	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	wafer resist$4 and membrane resist$4	2006-01-19 11:38:17
S37629	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(temperature measur$3 wafer) and "membrane"	2006-01-19 11:37:47
S37628	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	temperature measur$3 wafer	2006-01-19 11:30:05
S37627	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	temperature measur$3 substrate	2006-01-19 11:17:15
S37626	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (substrate adj temperature)) and (membrane adj5 temperature or temperature adj5 membrane)	2006-01-19 11:13:03
S37625	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (substrate adj temperature)) and (mebrane adj5 temperature or temperature adj5 membrane)	2006-01-19 11:09:30
S37624	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls.) and (substrate adj temperature)	2006-01-19 11:08:52
S37623	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (temperature adj5 substrate)) and (membrane adj5 temperature)	2006-01-19 11:00:49
S37622	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls. and (temperature adj5 substrate)) and (temperature adj membrane)	2006-01-19 11:00:24
S37621	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/$.ccls.) and (temperature adj5 substrate)	2006-01-19 10:59:50
S37620	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(substrate temperature and (membrane temperature)) and (resist$4)	2006-01-19 10:30:09
S37619	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(substrate	2006-

			temperature) and (membrane temperature)	01-19 10:29:35
S37618	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	substrate temperature	2006-01-19 10:29:19
S37617	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor and (substrate resist$4)) and (membrane)	2006-01-19 10:23:10
S37616	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor) and (substrate resist$4)	2006-01-19 10:20:54
S37615	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor and (substrate)) and (membrane)	2006-01-19 10:19:58
S37614	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor) and (substrate)	2006-01-19 10:19:48
S37613	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor) and (374/$.ccls.)	2006-01-19 10:19:14
S37612	U	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	mem sensor	2006-01-19 10:18:59

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Term: substrate resist$4 same membrane resist$4

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Set Name side by side	Query	Hit Count	Set Name result set
DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ			
L13	substrate resist$4 same membrane resist$4	3	L13
L12	substrate resist$4 same diaphragm resist$4	0	L12
L11	substrate resistir adj5 membrane resistor	0	L11
L10	substrate resistance adj5 membrane resistance	0	L10
L9	membrane in series substrate or substrate in series membrane	0	L9
L8	L7 and (membrane or diaphragm)	3	L8
L7	L6 and (substrate resistance or substrate resistor)	17	L7
L6	374/185	616	L6
L5	L4 and (substrate adj5 resistance)	276	L5
L4	(MEMBRANE OR DIAPHRAGM) adj5 (resistance)	11487	L4
L3	L2 and (MEMBRANE OR DIAPHRAGM)	7	L3
L2	L1 and (substrate or wafer)	74	L2
L1	374/29	293	L1

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DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ			
L43	L40 and (substrate temperature or substrate resistance)	16	L43
L42	L41 and (membrane or frame)	19	L42
L41	L40 and (substrate or wafer)	95	L41
L40	L1 and (temperature sens$4 resist$4 or temperature measur$4 resist$4)	391	L40
L39	(membrane resistor or resistor membrane) and (substrate resistor or wafer resistor)	14	L39
L38	(membrane resistance or resistance membrane) and (substrate resistance or wafer resistance)	16	L38
L37	L36 and (resistance substrate or resistance wafer)	7	L37
L36	resistance membrane	1689	L36
L35	thermistor on membrane	0	L35
L34	wafer resist$4 and membrane resist$4	4	L34
L33	L32 and "membrane"	0	L33
L32	temperature measur$3 wafer	53	L32
L31	temperature measur$3 substrate	53	L31

L30	L28 and (membrane adj5 temperature or temperature adj5 membrane)	6	L30
L29	L28 and (mebrane adj5 temperature or temperature adj5 membrane)	5	L29
L28	L1 and (substrate adj temperature)	290	L28
L27	L25 and (membrane adj5 temperature)	14	L27
L26	L25 and (temperature adj membrane)	0	L26
L25	L1 and (temperature adj5 substrate)	627	L25
L24	L23 and (resist$4)	17	L24
L23	L22 and (membrane temperature)	22	L23
L22	substrate temperature	41448	L22
L21	L20 and (membrane)	2	L21
L20	L16 and (substrate resist$4)	4	L20
L19	L18 and (membrane)	169	L19
L18	L16 and (substrate)	562	L18
L17	L16 and L1	1	L17
L16	mem sensor	807	L16
L15	L1 amd (MEM)	0	L15
L14	(substrate adj5 resistance) and (membrane adj5 resistance) and (temperature sensor or temperature indicator or thermal sensor)	7	L14
L13	(substrate resistance) and (membrane resistance) and (temperature sensor or temperature indicator or thermal sensor)	2	L13
L12	L1 and (temperature sens$3 substrate)	18	L12
DB=USPT; PLUR=YES; OP=ADJ			
L11	6131453.pn.	1	L11
DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ			
L10	L9 and (membrane adj5 resistance)	0	L10
L9	L1 and (substrate adj5 resistance)	83	L9
L8	L1 and (substrate resistance)	11	L8
L7	L6 and (substrate)	1	L7
L6	L1 and (membrane resistance)	3	L6
L5	L3 and (membrane resistance)	0	L5
L4	L3 and (membrane)	83	L4
L3	L2 and (substrate)	927	L3
L2	L1 and (temperature sens$3)	7420	L2
L1	374/$.ccls.	28929	L1

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